

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 1862

Taku HIRAYAMA et al.

Attorney Docket No. 2005 0892A

Serial No. 10/537,290

Group Art Unit 1752

Filed June 1, 2005

Examiner Sin J. Lee

CHEMICAL-AMPLIFICATION TYPE SILICONE-BASED POSITIVE-WORKING PHOTORESIST COMPOSITION

Mail Stop: AMENDMENT

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT **ACCOUNT NO 23-0975**

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of October 3, 2007.

The fee of \$120.00 is

- (X) submitted herewith.
- to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is 0
- Small entity status of this application is established by a Small Entity Status Assertion 0 which
 - is enclosed. 0
 - has been previously submitted. 0
 - has been previously asserted. ()

Respectfully submitted,

Taku HIRAYAMA et al.

By:

Matthew M. Jacob

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Attorney for Applicants

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